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Signature: Linda Cantrell



PATENT  
Docket No. P1296

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICANT(S): BIN YU

SERIAL NO.: 09/826,472

EXAMINER: RON E. POMPEY

FILED: APRIL 4, 2001

ART UNIT: 2812

FOR: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE  
HAVING A NITRIDE/HIGH-K/NITRIDE GATE DIELECTRIC STACK  
BY ATOMIC LAYER DEPOSITION (ALD) (as amended)

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WASHINGTON, DC 20231

TRANSMITTAL LETTER


Dear Sir:

In connection with the above-referenced patent application, transmitted herewith are the following:

1. Amendment After Final Rejection under 37 C.F.R. §1.116 (10 pages); and
2. Post card in acknowledgment of receipt of all transmitted materials.

Please date stamp and return the enclosed post card to the undersigned in acknowledgment of receipt of all transmitted materials.

Respectfully submitted,



May Lin DeHaan  
Reg. No. 42,472

MLD/pa  
Date: March 18, 2003  
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